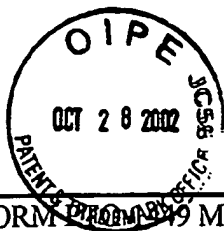




FORM 1449 MODIFIED				Docket No.: 2950.54US01		Application No.: 10/027,906	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION				APPLICANT: BI et al. FILING DATE: December 21, 2001 GROUP ART UNIT: 3662			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
9m10	3,806,570	04/1974	Flamenbaum et al.	—	—		
	3,883,336	05/1975	Randall	—	—		
	3,923,484	12/1975	Randall	—	—		
	3,932,162	01/1976	Blankenship	—	—		
	3,934,061	01/1976	Keck et al.	—	—		
	4,038,370	07/1977	Tokimoto et al.	—	—		
	4,113,844	09/1978	Tokimoto et al.	—	—		
	4,619,680	10/1986	Nourshargh et al.	—	—		
	4,735,677	04/1988	Kawachi et al.	—	—		
	4,791,648	12/1988	Vojak et al.	—	—		
	4,814,289	03/1989	Baeuerle	—	—		
	4,868,005	09/1989	Ehrlich et al.	—	—		
	4,881,791	11/1989	Mallinson et al.	—	—		
	4,933,262	06/1990	Beguin	—	—		
	5,060,595	10/1991	Ziv et al.	—	—		
	5,108,952	04/1992	Matsushashi	—	—		
	5,119,460	06/1992	Bruce et al.	—	—		
	5,141,549	08/1992	Tumminelli	—	—		
	5,195,161	03/1993	Adar et al.	—	—		
	5,200,029	04/1993	Bruce et al.	—	—		
	5,276,012	01/1994	Ushida et al.	—	—		
	5,296,072	03/1994	Dannoux et al.	—	—		
	5,317,576	05/1994	Leonberger et al.	—	—		
	5,318,614	06/1994	Beguin	—	—		
	5,385,594	01/1995	Kanamori et al.	—	—		
	5,396,507	03/1995	Kaminow et al.	—	—		
	5,447,585	09/1995	Dannoux et al.	—	—		
	5,448,586	09/1995	Shmulovich et al.	—	—		
	5,551,966	09/1996	Hirose et al.	—	—		
9m10	5,556,442	09/1996	Kanamori et al.	—	—		
EXAMINER SIGNATURE Mark Hellner				DATE CONSIDERED 9/22/2004			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

FORM 100-101 MODIFIED		Docket No.: 2950.54US01		Application No.: 10/027,906		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT: BI et al.				
		FILING DATE: December 21, 2001				
		GROUP ART UNIT: 3662				
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
cmg	5,622,750	04/1997	Kilian et al.	—	—	
	5,666,372	09/1997	Ball et al.	—	—	
	5,729,642	03/1998	Thaniyavarn	—	—	
	5,790,730	09/1998	Kravitz et al.	—	—	
	5,863,604	01/1999	Hunt et al.	—	—	
	5,870,417	02/1999	Verdiell et al.	—	—	
	5,874,134	02/1999	Rao et al.	—	—	
	5,885,904	03/1999	Mehta et al.	—	—	
	5,930,439	07/1999	Ojha et al.	—	—	
	5,958,348	09/1999	Bi et al.	—	—	
	5,966,478	10/1999	Marcuse et al.	—	—	
	5,997,956	12/1999	Hunt et al.	—	—	
	6,011,981	01/2000	Alvarez et al	—	—	
	6,032,871	03/2000	Börner et al.	—	—	
	6,074,888	06/2000	Tran et al.	—	—	
	6,097,144	08/2000	Lehman	—	—	
	6,137,933	10/2000	Hunter et al.	—	—	
	6,160,830	12/2000	Kiely et al.	—	—	
	6,177,290	01/2001	Jang et al.	—	—	
	6,193,936	02/2001	Gardner et al.	—	—	
cmg	6,227,722	05/2001	Kropp	—	—	
	6,254,928	07/2001	Doan	—	—	
	6,256,442	07/2001	Nolan et al.	—	—	
	6,280,802	08/2001	Akedo et al.	—	—	
	6,289,032	09/2001	Fay et al.	—	—	
	6,293,688	09/2001	Deacon	—	—	
	6,307,995	10/2001	Veligdan	—	—	
EXAMINER SIGNATURE Mark Hellner			DATE CONSIDERED 9/22/2004			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						



FORM 19 MODIFIED				Docket No.: 2950.54US01		Application No.: 10/027,906	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION				APPLICANT: BI et al.			
				FILING DATE: December 21, 2001			
				GROUP ART UNIT: 3662			
FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
MAU	WO 99/23189	05/1999	PCT	—	—		
	WO 99/31532	06/1999	PCT	—	—		
	WO 99/61244	12/1999	PCT	—	—		
	WO 00/24093	04/2000	PCT	—	—	Abstract only	
	WO 01/07155	02/2001	PCT	—	—		
	WO 01/22542	03/2001	PCT	—	—		
	WO 01/77732	10/2001	PCT	—	—		
MAU	WO 02/32588	04/2002	PCT	—	—		
	WO 02/44765	06/2002	PCT	—	—		
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)							
MAU	Rabii et al., "Recent advances in the fabrication of hollow glass waveguides", SPIE Vol. 3262, pp. 103-107, 1998.						
	Liang et al., "Laser synthesize silicon-based and ferro-based nano powders", SPIE Vol. 3862, pp. 17-21, 1999.						
	Barbarossa et al., "Effect of temperature gradient on sintering kinetics of doped silica waveguides by flame hydrolysis deposition", SPIE Vol. 1794 Integrated Optical Circuits II, pp. 191-197, 1992.						
	Lebedev et al., "Laser distillation-deposition synthesis of silica glasses with variable concentrations of oxygen deficient centers", SPIE Vol. 2498, pp. 65-71, 1995.						
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	Barbarossa et al., "High-silica low-loss three waveguide couplers on Si by Flame Hydrolysis Deposition", SPIE Vol. 1513 Glasses for Optoelectronics II, pp. 37-43, 1991.						
	Maxwell, "Photosensitivity & rare-earth doping in flame hydrolysis deposited planar silica waveguides", SPIE Vol. 2695, pp. 16-29, 1996.						
MAU	Sun et al., "Building passive components with silica waveguides", SPIE Vol. 3795, pp. 313-319, 1999.						
EXAMINER SIGNATURE Mark Hellner				DATE CONSIDERED 9/22/2004			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

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